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| APPLICATION NO.          | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. |
|--------------------------|-------------|----------------------|---------------------|------------------|
| 10/565,612               | 07/06/2006  | Bernhard Gellrich    | OST-051293          | 2423             |
| 22876                    | 7590        | 02/27/2009           | EXAMINER            |                  |
| FACTOR & LAKE, LTD       |             |                      | KIM, PETER B        |                  |
| 1327 W. WASHINGTON BLVD. |             |                      |                     |                  |
| SUITE 5G/H               |             |                      | ART UNIT            | PAPER NUMBER     |
| CHICAGO, IL 60607        |             |                      | 2851                |                  |
|                          |             |                      | MAIL DATE           | DELIVERY MODE    |
|                          |             |                      | 02/27/2009          | PAPER            |

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.



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FACTOR & LAKE, LTD  
1327 W. WASHINGTON BLVD.  
SUITE 5G/H  
CHICAGO, IL 60607

*In re Application of GELLRICH ET AL.*

Appl. No.: 10/565,612

Filed: July 06, 2006

For: MICROLITHOGRAPHIC PROJECTION APPARATUS  
AND METHOD FOR INTRODUCING AN  
IMMERSION LIQUID INTO AN IMMERSION SPACE

**WITHDRAWAL FROM ISSUE**  
*37 CFR 1.313*

The purpose of this communication is to inform you that the above identified application is being withdrawn from issue pursuant to 37 CFR 1.313.

The above-identified application is hereby withdrawn from issue. The Notice of Allowance and Issue Fee Due and the Notice of Allowability mailed 2/24/09, are hereby vacated.

The application is being withdrawn to permit reopening of prosecution. The reasons therefor will be communicated to you by the examiner in the next Office action.

U.S. Patent and Trademark Office records reveal that the issue fee and the publication fee have not been paid. If the issue fee and the publication fee have been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Fees Due, applicant may request that the previously submitted issue fee and publication fee be applied toward payment of the issue fee and publication fee in the amount identified on the new Notice of Allowance and Issue and Publication Fee Due. If the application is abandoned, applicant may request either a refund or a credit to a specified Deposit Account.

Telephone inquiries should be directed to Diane Lee at (571) 272-2399.

The above-identified application is being forwarded to the examiner for prompt appropriate action.

Cassandra Spyrou  
Director, ~~Acting~~  
Patent Examining Technology Center 2800  
Semiconductors, Electrical and Optical  
Systems and Components